

Jan Brunkwall, MD, PhD.

Jan Brunkwall, MD, PhD, is a Professor and Chairman at The Department of Vascular Surgery, University Clinic of Cologne in Germany. He earned his Medical Degree and a PhD from Lund University in Sweden and became an Intern Resident at the Department of Surgery in Halmstad, an Associate Professor of Surgery at Lund University, a Senior Resident and a Chief Surgeon for the Department of Surgery and Department of Vascular and Renal Diseases in Malmö General Hospital. In 1986-1987, Dr.Brunkwall was a Visiting Research Fellow at The Department of Surgery, University of Michigan in USA. He is a member of European Society for Vascular and Endovascular Surgery, European Board of Vascular Surgery, Assessor of the EBSQ-VASC Examinations 1996-2003, Assessor Chamber of Physics, North-Rhine Westfalen, International Society for Endovascular Surgery, German Society for Surgery, German Society for Vascular Surgery, German Society for Angiology, European Society for Surgical Research, Swedish Surgical Society, Swedish Society of Medicine, World Journal of Surgery and Annals of Vascular Disease. He also served as an organizer in many committees including ESVS, German Vascular Society and BCAGF (Brunkwall Cologne Aorticgrafting Fellowship). Prof.Brunkwall is a distinguished SVS fellow and an honorary member of The Colombian Society for vascular disease. a past president of The European Society for Vascular Surgery and The World Federation of Vascular Societies. He travels across the globe as a Visiting Professor in Cairo, Rostov an Don (Russia), Malmö and Charleston W Virginia. Awarded ESVS 1995 best experimental paper (with P. Mangell), ESVS 1998 best clinical paper (with M. Malina), ESVS 2004 best experimental paper (with J. Heckenkamp), and best presentation for The Scandinavian Society for Vascular Surgery in 1998. Editorial Board of VASA, Journal of Endovascular Therapy and Journal of Cardio-vascular Surgery with 280 publications in Vascular surgery and biology.

Notes:

-Bio (295 words)